Single-Atomic-Level Probe of Transient Carrier Dynamics by Laser-Combined Scanning Tunneling Microscopy

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The first application of laser-combined time-resolved scanning tunneling microscopy (STM) to single-atomic-level analysis was demonstrated. The dynamics of photoinduced holes, transiently trapped at the surface and recombined with the electrons tunneling from the STM tip to the in-gap states associated with single-(Mn,Fe)/GaAs(110) structures, was successfully probed on the atomic level for the first time. In addition, light-modulated scanning tunneling spectroscopy (LT-STS) was performed for energy–space analysis in conjunction with time-resolved measurement and shown useful for developing the laser-combined STM techniques for further advances. © 2013 The Japan Society of Applied Physics

The understanding and control of quantum dynamics, such as transition and transport in atomically controlled structures, are key factors for continuing the current advances of nanoscale science and technology. Scanning tunneling microscopy (STM) has been one of the most promising techniques widely used for the analysis of such properties because of its high spatial resolution.1,2) However, since its temporal resolution is low, approximately in the millisecond range, high-time-resolution STM has been an attractive target since its development.3–8) Recently, spin-polarized STM (SP-STM) has been combined with the inelastic excitation of electrons, and spin dynamics in a single atom has been successfully analyzed.9) With the electronic control of excitation, a subnanosecond time resolution was realized. Moreover, STM combined with ultrashort-pulse laser technology, such as the optical pump–probe method, has enabled us to study ultrafast dynamics with pulse-width time resolution, in principle, in the femtosecond range simultaneously with the atomic resolution of STM.9–16) Subnanoscale analyses on semiconductors by this microscopy technique have been reported with high time resolution provided by the ultrashort-pulse laser: however, single-atomic-level analysis taking advantage of STM has not yet been directly demonstrated until now.

In this paper, we show the results obtained by the first application of a laser-combined STM technique to the single-atomic-level analysis of transient photoexcited carrier dynamics. We also show the effect of an in-gap state, that is, the acceptor level formed by single-(Mn,Fe)/GaAs(110) structures, on the carrier dynamics directly probed for the first time.

In the time-resolved STM developed by the combination of STM with the optical pump–probe method using an ultrashort-pulse laser (Ti:sapphire laser with a pulse width of 140 fs in our case), the sample surface below the STM tip is illuminated with a train of paired optical pulses (i.e., pump and probe pulses, as in the optical pump–probe method), but the signal is tunneling current instead of, for example, the reflectivity of the probe pulse. Namely, tunneling current is measured as a function of the delay time \( t_d \) between pump and probe pulses. Although the signal is tunneling current, we call the two pulses in a pair the pump and probe pulses, similarly to in the optical pump–probe method.

To detect a weak time-resolved signal without the thermal expansion problem, the delay time \( t_d \), instead of the laser intensity, is modulated and used as the reference for the lock-in detection method.12) With the modulation of \( t_d \) between \( t_d^1 \) and \( t_d^2 \) using a pulse picker, the in-phase component obtained by the lock-in detection of the tunneling current gives \( \Delta I(t_d^1) = I(t_d^1) - I(t_d^2) \). As \( t_d^1 \) is set to a value larger than the relaxation time of the probed dynamics, \( \Delta I(t_d^1) \) can be approximated as \( \Delta I(t_d^1) \equiv I(t_d^1) - I(\infty) \), where \( I(\infty) \) is the tunneling current for a delay time sufficiently long for the excited state to be relaxed. Therefore, \( \Delta I(t_d^1) \) is accurately obtained through the lock-in detection of \( I \) by sweeping \( t_d^1 \). In addition, since the modulation can be performed at a high frequency (1 kHz in our case), the measurement is less affected by low-frequency fluctuations in laser intensity and tunneling current.

Accordingly, this method reduces the measurement time and hence enables the spatial mapping of time-resolved signals. Furthermore, since STM imaging is carried out simultaneously with the spectroscopic measurement, when the STM tip is being kept above a target position using a technique such as atom tracking,17) the measurement is expected to be possible even for a single-atomic-level structure, which is the method adopted in this study.

As the sample for this work, we chose a single-Mn/GaAs(110) structure, which is known to form an in-gap state, that is, an acceptor level.18–21) Transition metals in semiconductors play essential roles in producing magnetism in dilute magnetic semiconductors (DMSs).3) Recently, atomic-scale analyses have been carried out by STM to investigate the localized electronic structures of (Zn,Mn,Fe,C0)/GaAs(110), and the wavefunction mapping of in-gap states provided a detailed understanding of their characteristics.19) However, carrier dynamics via their electronic structures, for example, has not yet been analyzed on the atomic scale. Since the existence of in-gap states significantly affects the carrier dynamics in materials, understanding of such properties on the atomic level is extremely important. Among the DMSs, Ga\(_{1-x}\)Mn\(_x\)As is the most well-known prototypical example in this field, providing fundamental mechanisms. The Mn atoms in GaAs, for example, act as acceptors providing holes that are considered to mediate the ferromagnetic interaction between Mn 3d\(_z^2\)–core spins. If spin dynamics can be measured by microscopy, for example, in combination with circularly polarized light, magnetic phenomena can be included in the discussion.

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From these standpoints, the single-Mn/GaAs(110) structure is considered a good sample for the application of laser-combined STM to establish the technique of single-atomic-level analysis. For comparison, measurements were also carried out on a single-Fe/GaAs(110) structure.

Figure 1 shows a schematic diagram of the band structure, that is, the nanoscale metal–insulator–semiconductor (MIS) structure, formed by the STM tip, tunneling barrier and n-type semiconductor sample with an in-gap state. Under a reverse bias voltage condition between the STM tip and the sample, i.e., a positive sample bias voltage for the n-type semiconductor sample, the so-called tip-induced band bending (TIBB) is induced. When the sample surface is photoilluminated, the redistribution of photoexcited carriers, i.e., transient trapping of minority carriers (holes in this case) decreases the level of TIBB. The decrease in TIBB is called the surface photovoltage (SPV). SPV changes the tunneling barrier height, resulting in the change in STM tunneling current. Because of the lack of counter carriers (electrons in this case) at the surface, the density of trapped holes decreases via certain processes such as thermionic emission, resulting in a long time for the relaxation of SPV, typically \( \sim 200 \text{ ns} \). If there exists an in-gap state and tunneling current (electrons) directly flows from the STM tip into the in-gap state, however, the holes are recombined with the electrons at the in-gap state. There are two limiting factors, i.e., tunneling rate \( W \) and hole-capture rate \( C_p \). When the tunneling current is sufficient \( (W \gg C_p) \), the hole-capture rate becomes the limiting factor of the recombination process. In this case, the SPV induced by the pump pulse relaxes with the delay time due to the decay of the trapped holes with the decay constant \( \tau \sim 1/C_p \). On the other hand, the number of additional holes trapped at the surface by the probe-pulse excitation, which further increases the SPV, depends on the SPV remaining at the excitation (delay) time. Therefore, the time-resolved STM signal, which probes the change in tunneling current as a function of delay time, \( \Delta I(t_1) \), gives the hole-capture rate as \( C_p \sim 1/\tau \) (see Ref. 12 for detail).

Samples were prepared by the deposition of a small amount of Mn or Fe metal on a GaAs(110) cleaved surface (n-type: Si-doped, \( 1 \times 10^{17} \text{ cm}^{-3} \)) at room temperature. To analyze the recombination of the transiently trapped holes with the electrons tunneling from the STM tip, we used an n-type GaAs substrate.

Figures 2(a) and 2(b) show a typical STM image of the Mn/GaAs(110) surface and a magnification of the structures indicated by arrows in Fig. 2(a), respectively. When the image in Fig. 2(b) is compared with the STM images reported in previous papers, the structures indicated by arrows are single Mn atoms that occupy the Ga sites on the surface, as shown in the schematic model [Fig. 2(c)]. According to the previous work referred to above, the in-gap state formed is associated with the structure.

Since the sample is n-type, the acceptor level formed by Mn is occupied by electrons, and the tunneling current (electrons) from the STM tip does not flow into the in-gap state. Therefore, an additional technique is necessary to analyze the electronic structure of this system. We introduced light-modulated scanning tunneling spectroscopy (LM-STS) to measure current–voltage (I–V) curves. In LM-STS, I–V curves are generally measured under photolumination with chopping at 100 Hz. The holes produced by photoexcitation enable current flow, thereby, enabling the probing of the electronic structure of the sample. Accordingly, the I–V curves under dark and photoluminated conditions are obtained simultaneously over both positive and negative bias voltages. From the shift of the two I–V curves, we can estimate the magnitude of SPV for each bias voltage. A Ti:sapphire laser for time-resolved analysis, as well as a continuous-wave (CW) laser, can be used with the adjustment of intensity. Modulation at 100 Hz can be sufficiently fast with a low photointensity to reduce the thermal expansion effect of the STM tip and sample on the LM-STS measurement.

Figure 3 shows the LM-STS spectra obtained (a) above a single Mn atom and (b) over a bare GaAs surface, (c) a comparison between the two I–V curves obtained under photoillumination in (a) and (b), (d) the magnification of the rectangular area in (b), and (e) the maps of SPV for three bias voltages (lower three images), which are obtained from the LM-STS spectra measured over the topographic image (top image) (see Ref. 24 for detail). In the I–V curve measured above a single Mn atom under photoillumination, there is a broad shoulder with a maximum at \( \sim 0.8 \text{ eV} \).
 increase in tunneling current for voltages higher than the 
\( \sim 0.8 \) eV peak. On the other hand, for a negative sample 
bias voltage, electrons, which are the majority carriers of this 
sample, may tunnel from the conduction band to the STM tip 
when band bending becomes almost flat, which corresponds 
to the change in the sign of the tunneling current observed 
in Fig. 3(c). When the Fermi level of the W tip reaches the 
acceptor level and then the valence band edge, the current, 
i.e., electrons tunneling from the valence band to the STM 
tip, emerges in the spectrum.

As shown in Fig. 3(d), SPV, i.e., the shift of 
\( I-V \) curves between the cases with and without photoillumination, 
is observed until the negative bias voltage reaches \( \sim -2.0 \) V. 
Furthermore, the bias-voltage dependence of SPV, shown 
in the spatial maps of SPV [Fig. 3(e)], clearly shows that the 
SPV is lower at the Mn site. These results indicate that the 
upward band bending exists even for a negative sample bias 
voltage, owing to the effect of the in-gap state formed by the 
single-Mn/GaAs structure.

To prepare the conditions under which the hole-capture 
rate becomes the limiting factor of the process \( \left( W \gg C_p \right) \), we 
adjusted the laser intensity by observing the change in the 
STM image of the single-Mn structure. Namely, when the 
condition of \( W \gg C_p \) is satisfied, the STM image shows a 
centrosymmetric depression at the Mn site as observed in the 
change in the STM image from Figs. 5(a) to 5(b) for \( V_i = +2.0 \) V, 
owing to the charging effect at the Mn site. The bias 
voltage for the time-resolved measurement was set at \( +2.0 \) V, 
at which the injection of electrons from the STM tip to the 
in-gap state occurs and the GaAs area can be imaged. The direct 
recombination of electrons tunneling from the STM tip with 
holes in the valence band was negligible. In fact, when time-
resolved measurement was carried out above a bare GaAs 
surface, the decay constant was typically \( \sim 200 \) ns.

In addition, to realize single-atomic-level measurement, 
we adopted an atom tracking technique.\(^{[17]} \) As shown in the 
cross section in Fig. 5(c) along the line in Fig. 5(b), a depression 
at the Mn site is traced when the measurement condition 
discussed above is satisfied. Therefore, the STM tip position 
can easily be estimated if the STM tip is scanned above the 
single Mn atom during the time-resolved STM measurement. 
When the STM tip began to probe the edge of the slope of the 
depression structure [Fig. 5(c)], the position of the STM tip 
was determined by fitting the spectrum.
with an exponential function, and the obtained value is 1.6 ns. This is the first result obtained by the application of laser-combined-time-resolved STM to single-atomic-level analysis.

For comparison, in consideration of further advances, we applied the microscopy technique to the analysis of a single-Fe/GaAs structure which has a similar structure to the single-Mn/GaAs structure [Fig. 2(c)] with an in-gap state.\(^\text{19}\) Figure 6 shows typical STM images of the Fe/GaAs structure [similar to Fig. 2(c)] and a time-resolved signal obtained above the single Fe atom in the structure. The decay constant obtained by exponential fitting of the spectrum is 14.3 ns, above the single Fe atom in the structure. The difference in energy which is ten times larger than that obtained for Mn (1.6 ns).

in conjunction with time-resolved measurement, which is useful for optimizing the conditions for time-resolved measurement. An atom tracking technique is useful for realizing reliable measurement when phenomena such as thermal drift exist. With the techniques developed in this study, laser-combined STM is expected to enable further advances.

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